



S/N 09/909,532

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|--|-----------------|----------------|
| Applicant: | Kie Y. Ahn et al. | Examiner: | Maria Guerrero |
| Serial No.: | 09/909,532 | Group Art Unit: | 2822 |
| Filed: | July 20, 2001 | Docket No: | 303.377US3 |
| Title | POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR | | |

PETITION FOR A THREE-MONTH EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a three-month extension of time be granted in which to respond to the Office Action mailed September 16, 2003, said period of response being extended from December 16, 2003 to March 16, 2004.

Our check in the amount of \$950.00 is enclosed to cover the required extension fee.
Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.

Respectfully Submitted

KIE Y. AHN ET AL.

By their Representatives,

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(612) 349-9587

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Date:

16 March '04

By:

Timothy B. Clise
Reg. No: 40,957

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelop addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 16th day of March 2004.

Name: _____

Signature: _____